



07/27/01

Docket No. 006015/DISPLAY/AKT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application  
 Assistant Commissioner for Patents  
 Washington, D.C. 20231

Re: Inventor(s): **Tae Kyung Won, Soo Young Choi, Takako Takehara and William R. Harshbarger**  
 Title: **Reduction of Electrostatic Charge on a Substrate during PECVD Process**



Transmitted herewith is the patent application identified above, including:0

- ☒ Specification, claims and abstract, totaling 30 pages.
- ☒ Drawings totaling 3 pages,    Formal ☒ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☒ Assignment of the invention to Applied Materials, Inc.
- ☒ Assignment Recordation Cover Sheet
- ☒ Information Disclosure Statement, PTO Form 1449 and (2) References

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	- 35	- 20 =	-15	X \$18	\$270
Independent Claims	- 5	- 3 =	-2	X \$80	\$160
Basic Filing Fee				\$710	\$710
TOTAL FEES					\$1140

- ☒ The Commissioner is hereby authorized to charge \$1140 to Deposit Account No. 50-1074
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:

**PATENT COUNSEL  
 APPLIED MATERIALS, INC.  
 Legal Affairs Department  
 P.O.BOX 450A  
 Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231

Express Mail Receipt No. EL 27612365465

Date of Deposit 7-27-01

Signature Robert W. Mulcahy

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Respectfully submitted,

*Robert W. Mulcahy*  
 Robert W. Mulcahy  
 Registration No. 25,436